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# REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

Subsection (b) of 35 U.S.C. § 132, effective on May 29, 2000, provides for the continued examination of a utility or plant application filed on or after June 8, 1995.

Application Number	09/765,437	
Filing Date	January 22, 2001	
First Named Inventor	SUZUKI, Toshiya	
Group Art Unit	2822	
Name of Examiner	GUERRERO, MARIA F.	
Attorney Docket No.	001764	

CF 12825

This is a Request for Continued Examination (RCE) under 37 C.F.R. § 1.114 of the above-identified application.

Note: 37 C.F.R. §1.114 is effective on May 29, 2000. If the above-identified application was filed prior to May 29, 2000, applicant may wish to consider filing a continued prosecution application (CPA) under 37 C.F.R. §1.53 (PTO/SB/29) instead of a RCE to be eligible for the patent term adjustment provisions of the AlPA. See changes to Application Examination and Provisional Application Practice, Interim Rule, 65 Fed. Reg. 14865 (Mar 20, 2000) 1233 Off. Gazette Pat Office (April 11, 2000) which established RCE practice.

1. Submission Required Under 37 C.F.R. § 1.114	
a. Previously submitted	
i. Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on  (Any unentered amendment(s) referred to above will be entered)	
ii. $\square$ Consider the arguments in the Appeal Brief or Reply Brief previously filed on	
iii. Other	
b. 🗵 Enclosed	OLOC FEB (EC
i. 🛮 Amendment/Reply	) 25 6) 6
ii.	RECEIVED FEB 25 200 NOLOGY CENTE
iii.	# W
iv. Other	. 2800
<ul> <li>Miscellaneous</li> <li>a. □ Suspension of Action on the above-identified application is requested under 37 C.F.R. § months (period shall not exceed three months; Fee under 37 C.F.R. §1.17(i)</li> </ul>	31.103(c) for a period of
b. \( \text{Other: Amendment Transmittal and Petition for Extension of Time are enclosed.} \)	roquirou)
The RCE fee under 37 C.F.R. §1.17(e) is required by 37 C.F.R. §1.114 when the Range a.   The Director is hereby authorized to charge the following fees, or credit any overpayments.	
Account No. 01-2340	
i. RCE fee required under 37 C.F.R. § 1.17 (e)	
ii. Extension of Time Fee (37 C.F.R. §§ 1.136 and 1.17)	
iii. Other	
b.	\$110.00 for one-month

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Atty Docket No.

001764

	SIGNATURE BY APPLICANT, ATTORNEY, OR AGENT REOUIRED				
Name	Sadao Kinashi	Registration No. 48,075 (atty/agent)			
Signatur	· Sadao	Knach' Date February 21, 2003			
		CERTIFICATE OF MAILING OR TRANSMISSION			
	d to Commissioner for Pa	ondence is being deposited with the United States Postal Service as first class mail in an envelope tents, BOX RCE, Washington, D.C. 20231, or facsimile transmitted to the U.S. Patent and Trademark			
Name					
Signatu	re				

FEB 26 2003
TECHNOLOGY CENTER 2800



#### E UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

SUZUKI, Toshiya

Serial No.: 09/765,437

Filed: January 22, 2001

Group Art Unit: 2822

Examiner: GUERRERO, M.

P.T.O. Confirmation No.: 9007

SEMICONDUCTOR DEVICE HAVING A CAPACITOR WITH RARE METAL

**ELECTRODE** (as amended)

#### **AMENDMENT**

Commissioner for Patents Washington, D.C. 20231

February 21, 2003

Sir:

For:

In response to the Office Action dated October 21, 2002, please amend the above-identified application as follows:

### IN THE CLAIMS:

Please CANCEL claim 17 without prejudice or disclaimer.

Please AMEND claims as follows:

- 15. (Amended) A method of manufacturing a semiconductor device, comprising the steps of:
- (a) forming a rare metal layer above a semiconductor substrate formed with semiconductor

elements;

- (b) forming an insulating mask layer on the rare metal layer;
- (c) patterning the insulating mask layer by using a resist pattern;
- (d) pattering the rare metal layer by using the patterned insulating mask layer; and

02/24/2003 JBALINAN 00000128 0976543;